PROCEEDINGS OF SPIE

MOEMS and Miniaturized Systems XV

Wibool Piyawattanametha Yong-Hwa Park *Editors*

15–17 February 2016 San Francisco, California, United States

Sponsored by SPIE

Cosponsored by Samsung Advanced Institute of Technology (Korea, Republic of)

Published by SPIE

Volume 9760

Proceedings of SPIE 0277-786X, V. 9760

SPIE is an international society advancing an interdisciplinary approach to the science and application of light.

MOEMS and Miniaturized Systems XV, edited by Wibool Piyawattanametha, Yong-Hwa Park, Proc. of SPIE Vol. 9760, 976001 · © 2016 SPIE CCC code: 0277-786X/16/\$18 · doi: 10.1117/12.2240460

Proc. of SPIE Vol. 9760 976001-1

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ISSN: 0277-786X ISSN: 1996-756X (electronic) ISBN: 9781628419955

Published by **SPIE** P.O. Box 10, Bellingham, Washington 98227-0010 USA Telephone +1 360 676 3290 (Pacific Time) · Fax +1 360 647 1445 SPIE.org

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